

03500.017456

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KAZUHIRO KAGAMI ET AL.

Application No.: 10/627,645

Filed: July 28, 2003

For: BASE PATTERN FORMING
MATERIAL FOR ELECTRODE
AND WIRING MATERIAL
ABSORPTION, ELECTRODE
AND WIRING FORMING
METHOD, AND METHOD OF
MANUFACTURING IMAGE
FORMING APPARATUS

)
:
Examiner: Not Yet Assigned

)
:
Group Art Unit: Not Yet Assigned

)
:
August 20, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449. Since the U.S. Patent and Trademark Office waived the requirement under 37 C.F.R. § 1.98 (a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. patent application publication for all U.S. national patent applications filed after June 30, 2003 and for all international applications that have entered the national stage under 35 U.S.C. § 371 after June 30, 2003, no copies of such documents are enclosed. Copies of the other listed documents are, however, enclosed.

The concise explanation of relevance for the non-English documents may be found, inter alia, in the specification where they are cited and/or in the English language

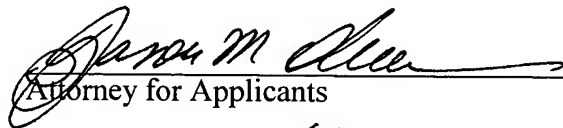
abstracts attached thereto. In addition, the concise explanation of relevance for JP 8-185818 may be found in corresponding U.S. Patent Nos. 6,137,218 and 6,283,813 B1. The concise explanation of relevance for JP 8-236017 may also be found in corresponding U.S. Patent Nos. 5,996,488 and 6,457,408 B1. The concise explanation of relevance for JP 8-176177, JP 2001-297639 and JP 2003-31922 may also be found, respectively, in corresponding U.S. Patent Nos. 5,696,384 and 6,586,155 B2 and U.S. Patent Application Publication No. 2003/0026959 A1.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


Attorney for Applicants

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FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				ATTY DOCKET NO. 03500.017456		APPLICATION NO. 10/627,645	
APPLICANT Kazuhiro Kagami et al.				FILING DATE July 28, 2003		GROUP N.Y.A.	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6,137,218	10/24/00	Kaneko et al.	313	495	
		6,283,813 B1	09/04/01	Kaneko et al.	445	24	
		5,996,488	12/07/99	Yanagisawa et al.	101	170	
		6,457,408 B1	10/01/02	Yanagisawa et al.	101	170	
		5,696,384	12/09/97	Ogi et al.	252	182.12	
		6,586,155 B2	07/01/03	Furuse et al.	430	270.1	
		2003/0026959 A1	02/06/03	Furuse et al.	428	195	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	JP	8-185818	07/16/96	Japan			Abstract
	JP	8-236017	09/13/96	Japan			Abstract
	JP	5-114504	05/07/93	Japan			Abstract
	JP	8-176177	07/09/96	Japan			Abstract
	JP	2001-297639	10/26/01	Japan			Abstract
	JP	2003-31922	01/31/03	Japan			Abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.